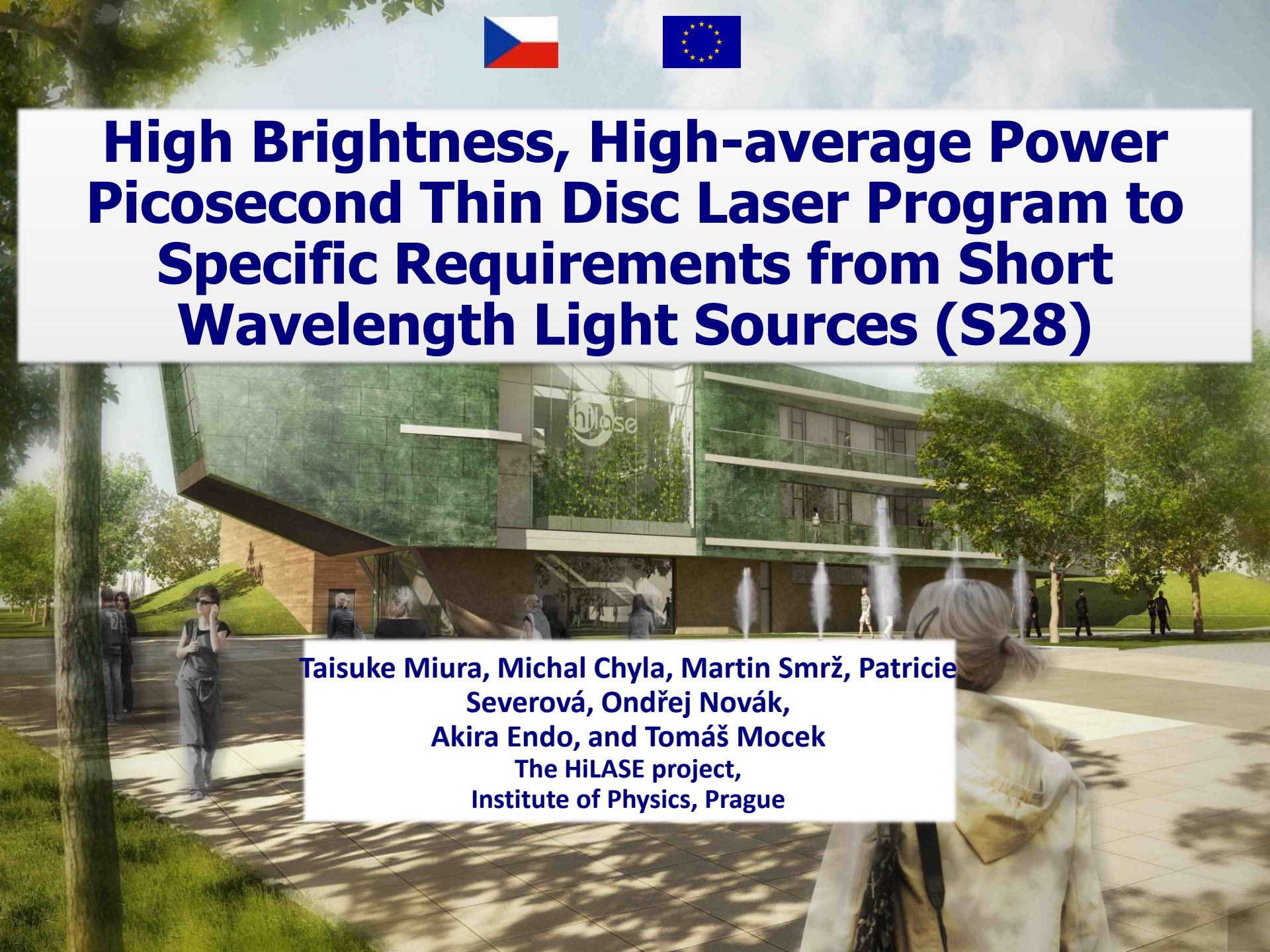




# High Brightness, High-average Power Picosecond Thin Disc Laser Program to Specific Requirements from Short Wavelength Light Sources (S28)

An architectural rendering of a modern, multi-story building with a green, textured facade and large glass windows. The building is surrounded by lush greenery, trees, and a paved plaza with people walking. The HiLASE logo is visible on the building's facade.

Taisuke Miura, Michal Chyla, Martin Smrž, Patricie  
Severová, Ondřej Novák,  
Akira Endo, and Tomáš Mocek  
The HiLASE project,  
Institute of Physics, Prague

# Overview of The HiLASE Project



- HiLASE: High average power pulsed LASErs
- European project on strategic development of advanced solid-state laser technologies based on diode pumping (thin-disk laser, multi-slab laser)
- Potential for novel industrial applications using pulsed, high-energy & high-average power DPSSL
- Motivated by strong need for head-start laser technology development & prototyping for the next generation of high-energy, large scale laser facilities (ELI Beamlines, HiPER)
- Implementation phase: 09/2011- 08/2015
- Application phase: 2015-

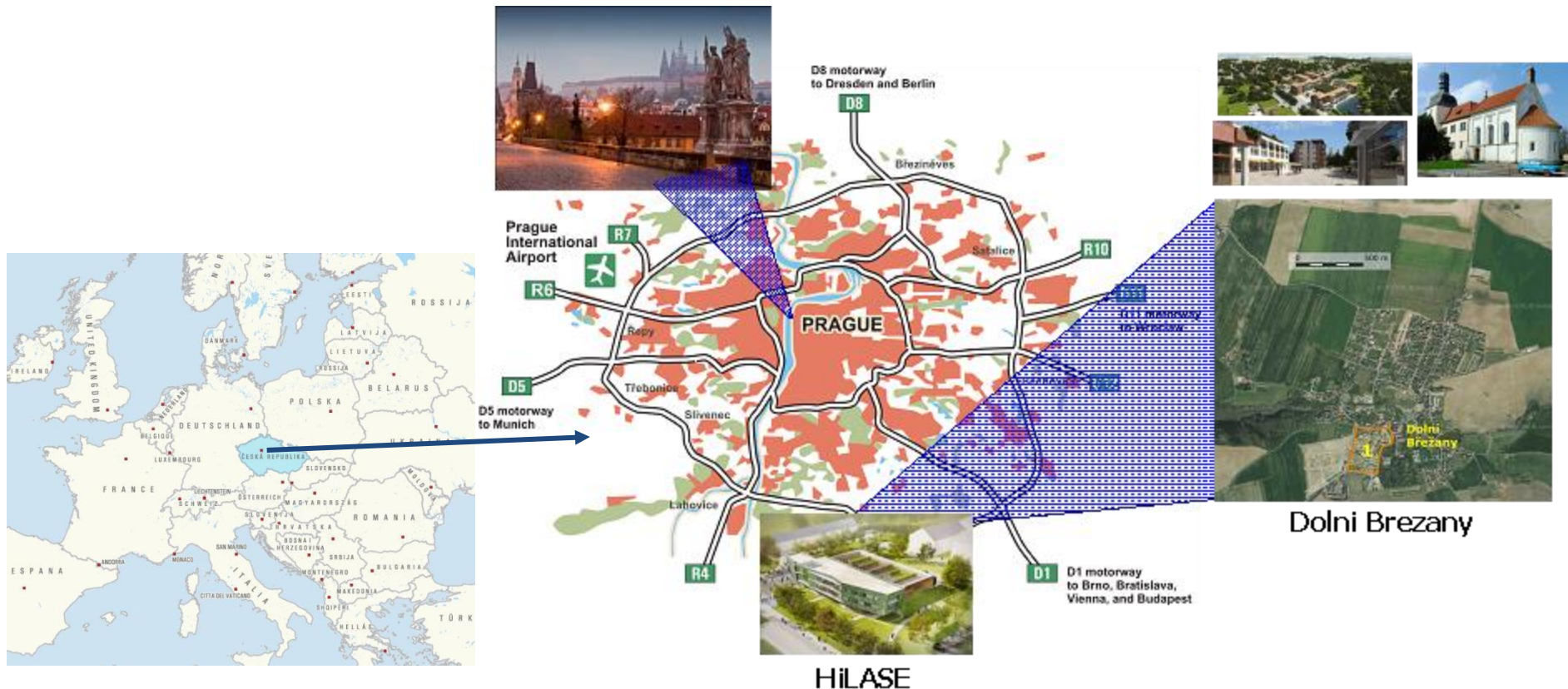




# Location of The HiLASE Project



- Area of future **R&D centres** south of Prague city, enjoyable surroundings
- Synergy with **ELI** (on site) and biotechnology center **BIOCEV** (at 2 km distance)
- Fast connection (20 min.) to Ruzyne international airport



# HiLASE team



PM

T. Mocek

RP-1

A. Endo, T. Miura, M. Smrž, O. Novák, M. Chyla, P. Severová,  
Shiva Shankar. N

RP-2

A. Lucianetti, M. Divoký, O. Slezák, M. Sawicka, P. Sikocinski,  
V. Jambunathan, J. Pilař, V. Kmetík

RP-3

D. Rostohar, J. Vanda, L. Gemini, R. Švábek, Ch. Liberatore

Technical sup.

M. Řeháková, V. Červenka, L. Švandrlík, J. Kadlec, H. Vohníková

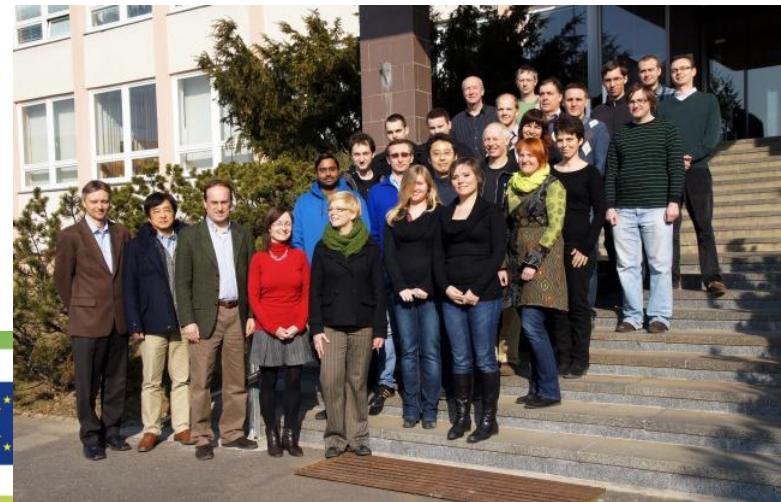
Admin. sup.

L. Masopust, I. Vrbová, J. Svojšová, V. Svoboda, M. Vanková,  
J. Kavanová, J. Černý, R. Tůma, R. Kozáková, R. Karešová

10 / 2012 36 staff

08 / 2015 55 FTE

50% of our research staff is from abroad.

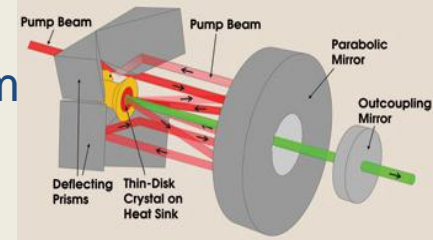


# Project Activities of the HiLASE



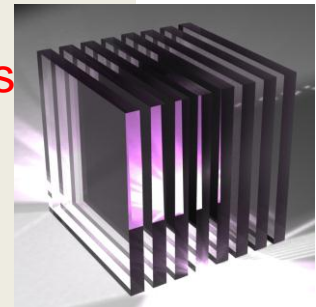
- **HiLASE Research Program 1** (Thin disk laser)

- Development of multi-J, kW class **ps** thin-disk laser system
- Mainly focused on medical and industrial applications
- Three beam lines with different beam parameters



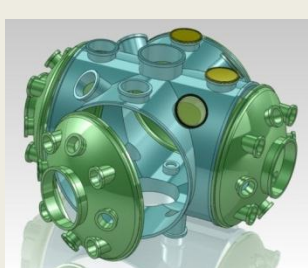
- **HiLASE Research Program 2** (Multi slab laser)

- Development of 100 J / 10 Hz cryogenically cooled multi-slab **ns** DPSSL system scalable to kJ level
- Applications: Laser-induced damage threshold test (LIDT), Laser peening, Pumping source of OPCPA in the ELI project

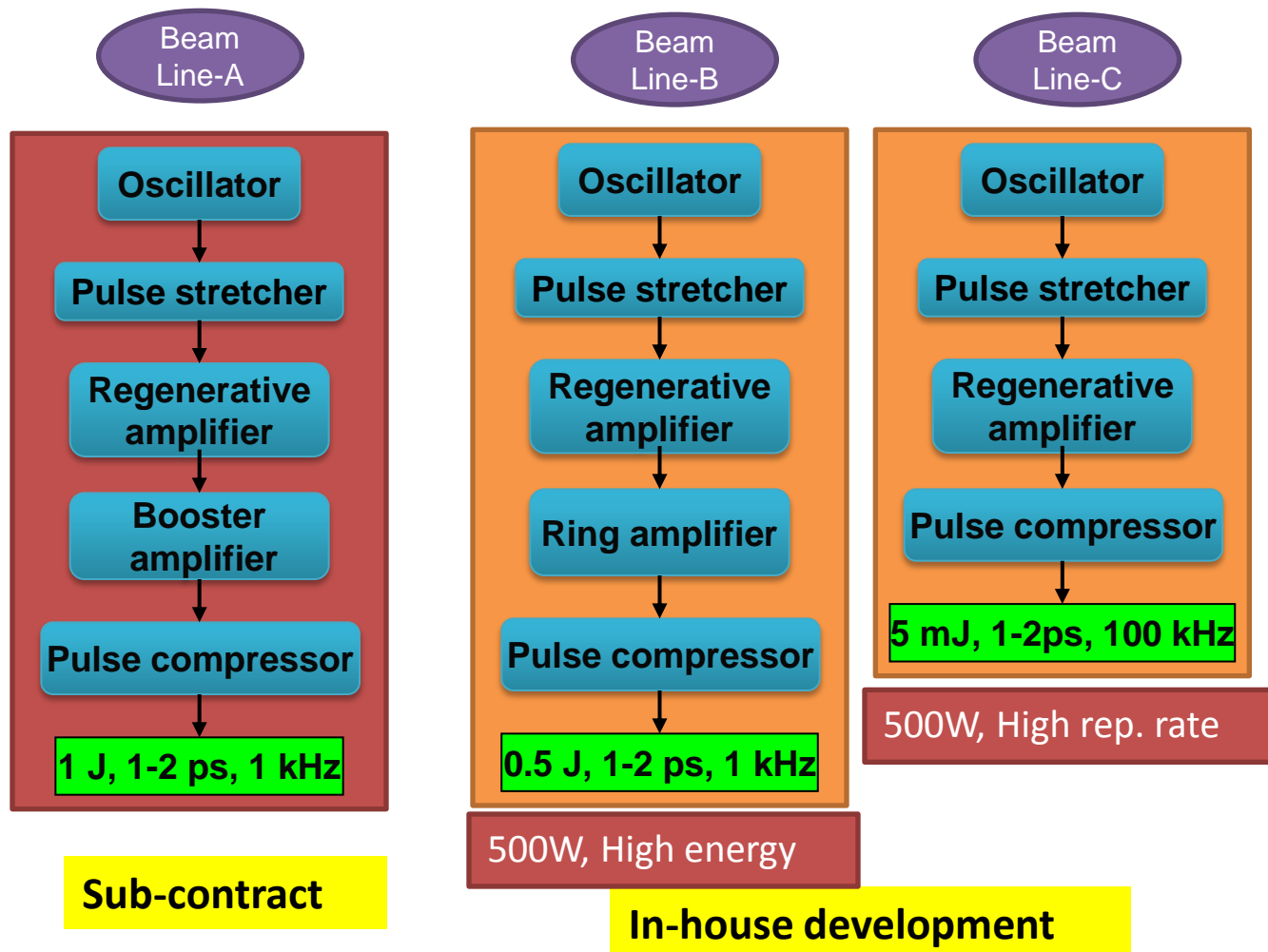


- **HiLASE Research Program 3** (Applications)

- Using RA1 and RA2 lasers for industrial applications
- Applications:
  - EUV(13.5 nm) and Beyond-EUV(6.x nm) light source based on laser-induced plasma,
  - Short pulse X-ray sources based on laser-Compton scattering for biomedical imaging
  - LIDT and Laser peening



# Beam Lines of RP1

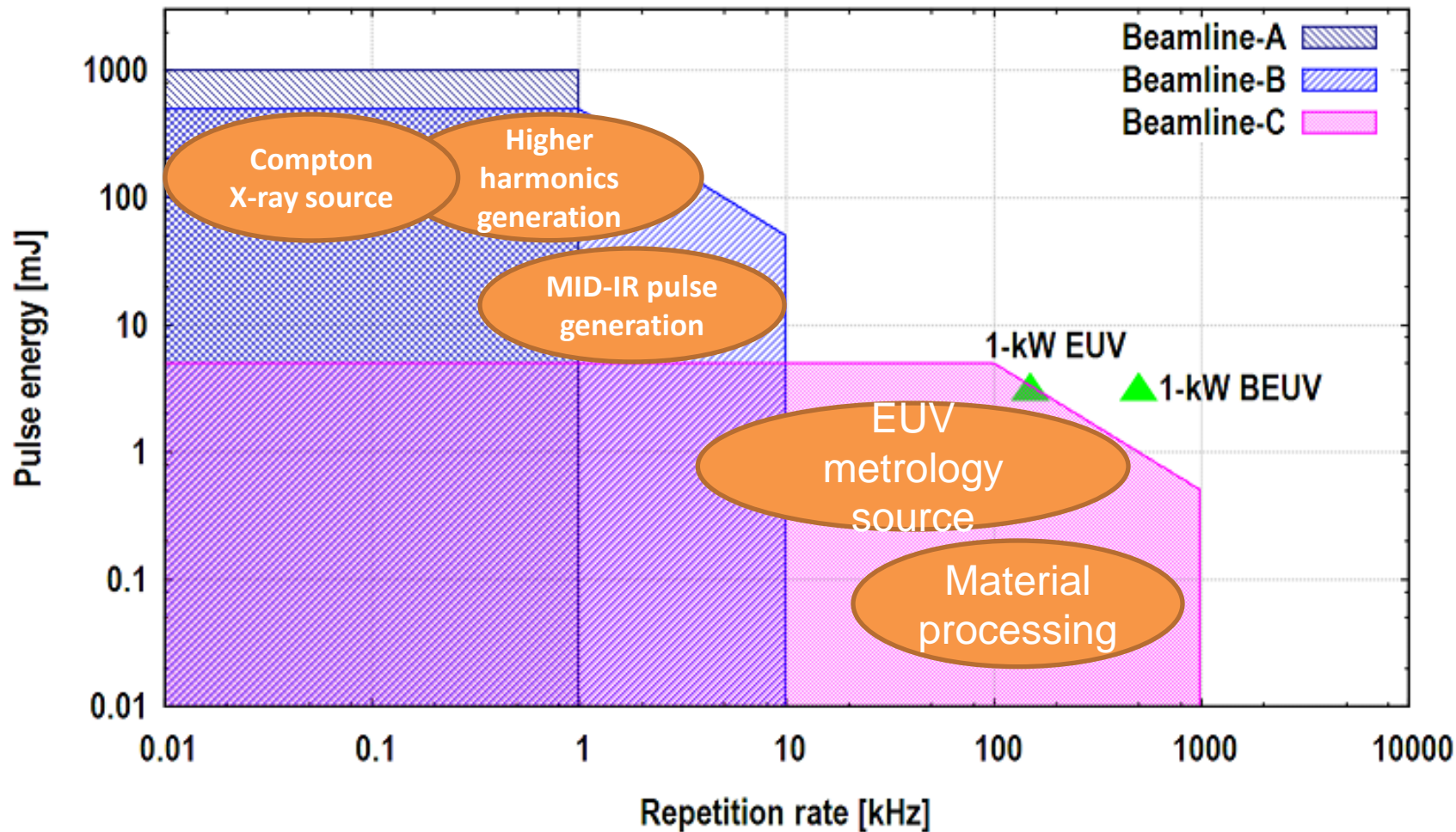


Priority issues of beam line B & C

- High beam quality
- High reliability
- Small footprint
- Cost effective



# Industrial and Medical Applications Using High Energy Picosecond Pulse



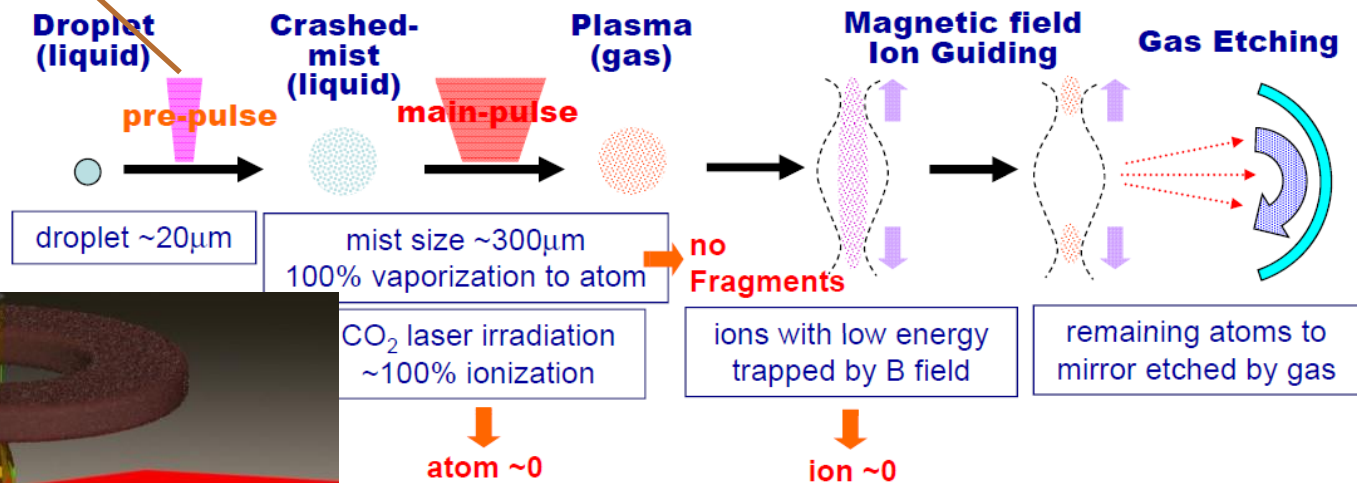
# Pre-pulse Laser for High Volume Machine EUV/BEUV Lithography



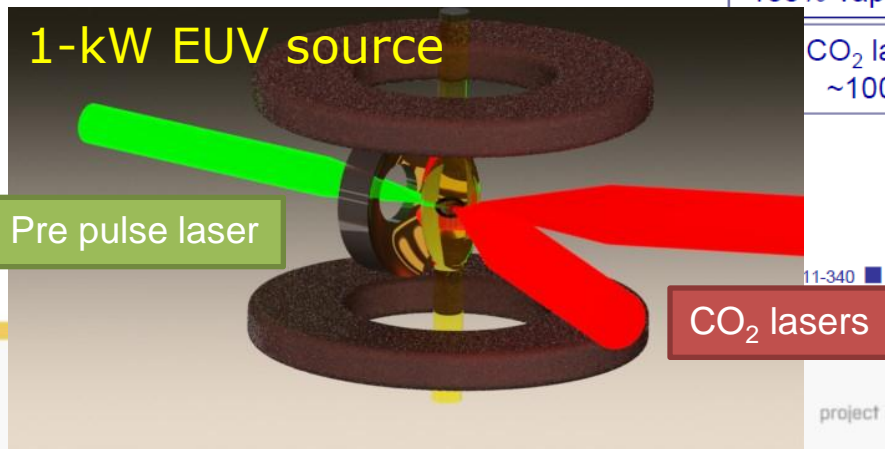
## Debris mitigation concept

- Double pulse laser irradiation
- Magnet field is effective for guiding ions
- Gas etching

- Solid-state laser
- 3.3 mJ
- 150 kHz
- (500 W)
- <10 ns



## 1-kW EUV source



**KOMATSU**

[8322-14] SPIE 2012 Advanced Lithography, February 14, 2012, P11

project supported by:



EUROPEAN UNION  
EUROPEAN REGIONAL DEVELOPMENT FUND  
INVESTING IN YOUR FUTURE



OP Research and  
Development for Innovation



# 6.Xnm Beyond EUV (BEUV) Source

APPLIED PHYSICS LETTERS **100**, 061118 (2012)

## Optimizing conversion efficiency and reducing ion energy in a laser-produced Gd plasma

Thomas Cummins,<sup>1,a)</sup> Takamitsu Otsuka,<sup>2</sup> Noboru Yugami,<sup>2,3</sup> Weihua Jiang,<sup>4</sup> Akira Endo,<sup>5</sup> Bowen Li,<sup>1</sup> Colm O'Gorman,<sup>1</sup> Padraig Dunne,<sup>1</sup> Emma Sokell,<sup>1</sup> Gerry O'Sullivan,<sup>1</sup> and Takeshi Higashiguchi<sup>2,3</sup>

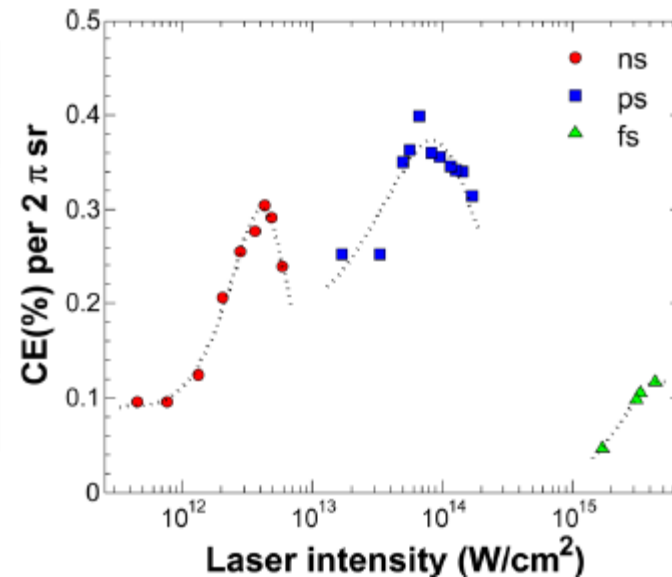
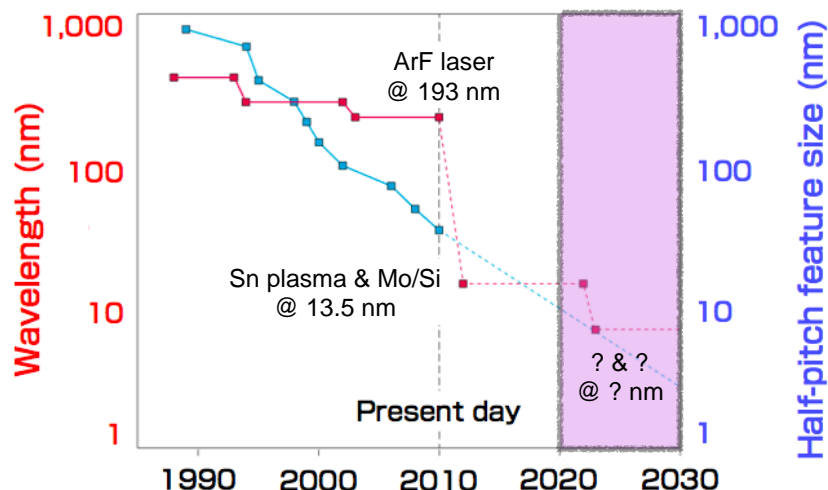
<sup>1</sup>School of Physics, University College Dublin, Belfield, Dublin 4, Ireland

<sup>2</sup>Department of Advanced Interdisciplinary Sciences, Center for Optical Research and Education (CORE), and Optical Technology Innovation Center (OpTIC), Utsunomiya University, Yoto 7-1-2, Utsunomiya, Tochigi 321-8585, Japan

<sup>3</sup>Japan Science and Technology Agency, CREST, 4-1-8 Honcho, Kanagawa, Saitama 332-0012, Japan

<sup>4</sup>Department of Electrical Engineering, Nagaoka University of Technology, Kami-tomiokamachi 1603-1, Nagaoka, Niigata 940-2188, Japan

<sup>5</sup>Research Institute for Science and Engineering, Waseda University, Okubo 3-4-1, Shinjuku, Tokyo 169-8555, Japan



For laboratory use

- Solid-state laser
- 100-200 mJ
- 1 kHz
- 1-100 ps

# In-line Phase Contrast Imaging of A Biological Specimen

APPLIED PHYSICS LETTERS 92, 131107 (2008)

## In-line phase-contrast imaging of a biological specimen using a compact laser-Compton scattering-based x-ray source

H. Ikeura-Sekiguchi,<sup>1,a)</sup> R. Kuroda,<sup>1</sup> M. Yasumoto,<sup>1</sup> H. Toyokawa,<sup>1</sup> M. Koike,<sup>1</sup> K. Yamada,<sup>1</sup> F. Sakai,<sup>2</sup> K. Mori,<sup>3</sup> K. Maruyama,<sup>3,b)</sup> H. Oka,<sup>4</sup> and T. Kimata<sup>4</sup>

<sup>1</sup>National Institute of Advanced Industrial Science and Technology (AIST), Central 2-5, 1-1-1 Umezono, Tsukuba, Ibaraki 305-8568, Japan

<sup>2</sup>Sumitomo Heavy Industries, Ltd. (SHI), 2-1-1, Yatocho, Nishitokyo, Tokyo 188-8585, Japan

<sup>3</sup>Ibaraki Prefectural University of Health Sciences, 4669-2, Ami, Inashiki, Ibaraki 300-0394, Japan

<sup>4</sup>St. Marianna University School of Medicine, 2-16-1, Sugao, Miyamae-ku, Kawasaki City 216-8512, Japan

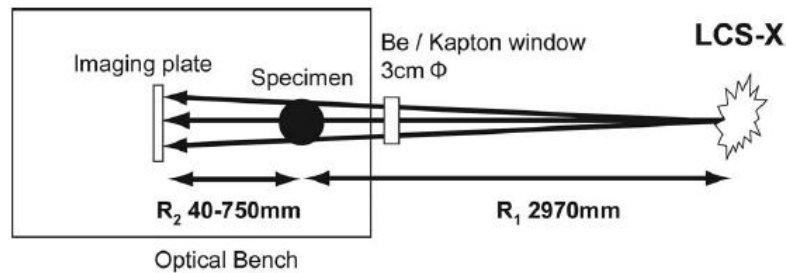


FIG. 1. Schematic drawing of in-line phase-contrast imaging using LCS x ray at AIST.

0.5-1 J, 1 ps pulse

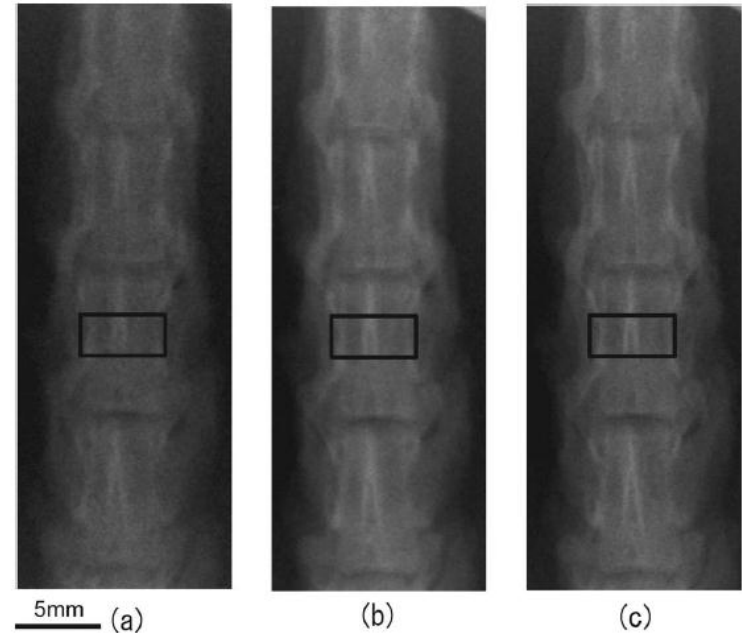
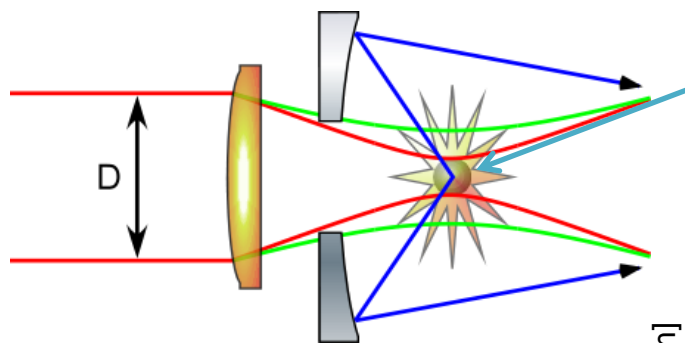


FIG. 2. Effect of increasing propagation (sample-to-detector) distance  $R_2$  on images of rat lumbar vertebrae in frontal projection. Images were recorded using an LCS x ray using an energy of 30 keV: (a)  $R_2=40$  mm, (b)  $R_2=200$  mm, and (c)  $R_2=750$  mm.

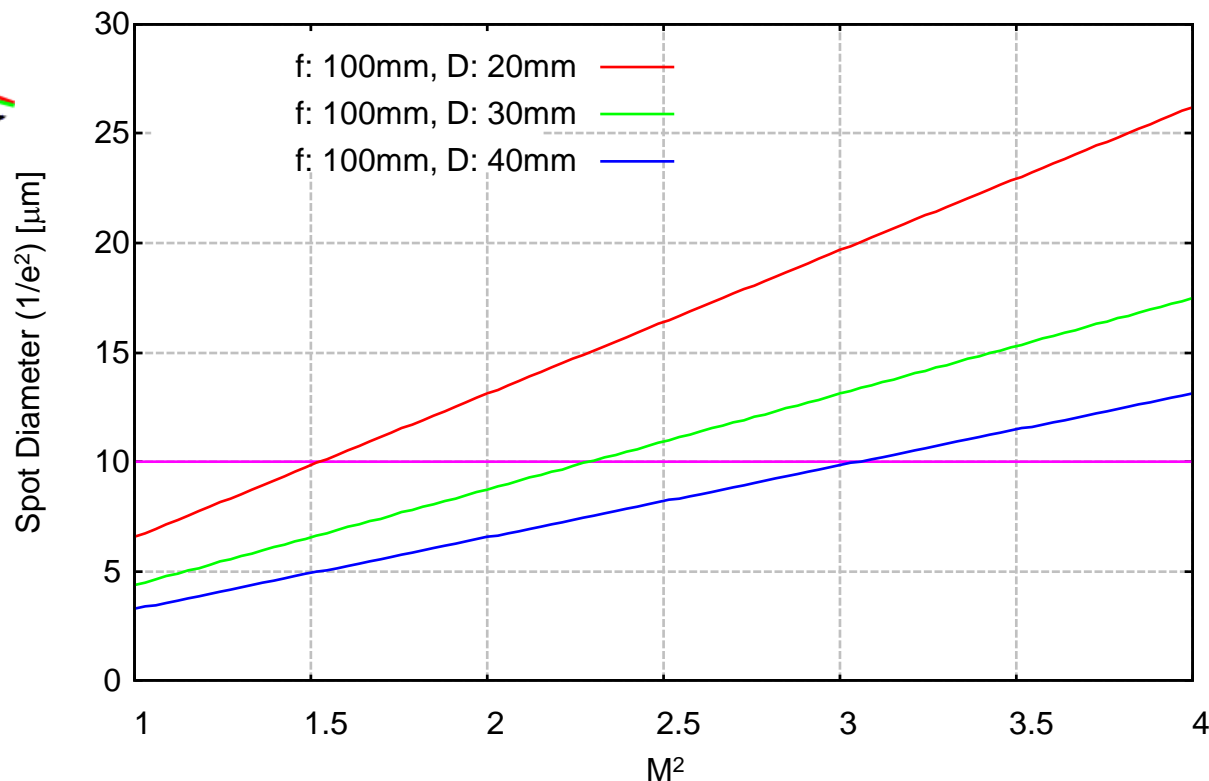
Exposure time: 1800 sec

# Focusing Property of Driving Laser for EUV, BEUV, X-ray Pulse Generation



Target size:  $\phi 10\mu\text{m}$

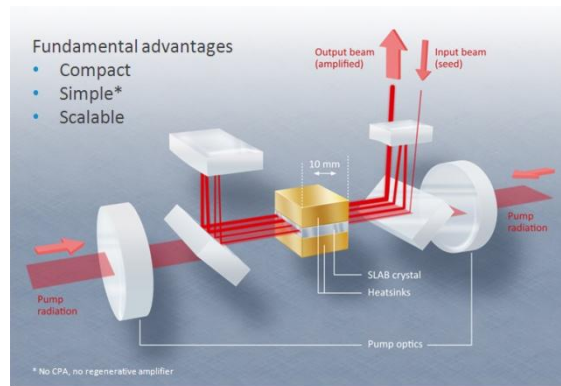
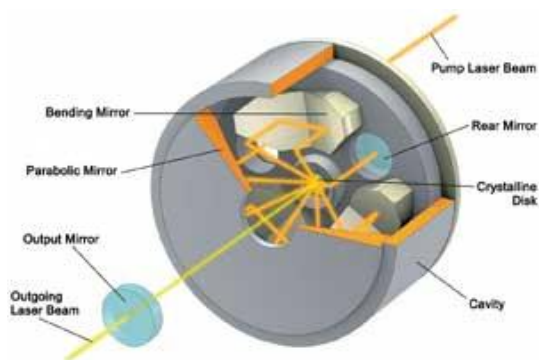
- Target size:  $10\mu\text{m}$   
Focal length of lens:  $f=100\text{mm}$
- $D=20\text{mm}$   
 $M^2 < 1.5$
  - $D=30\text{mm}$   
 $M^2 < 2.3$
  - $D=40\text{mm}$   
 $M^2 < 3$





# High Energy Picosecond Pulse Sources

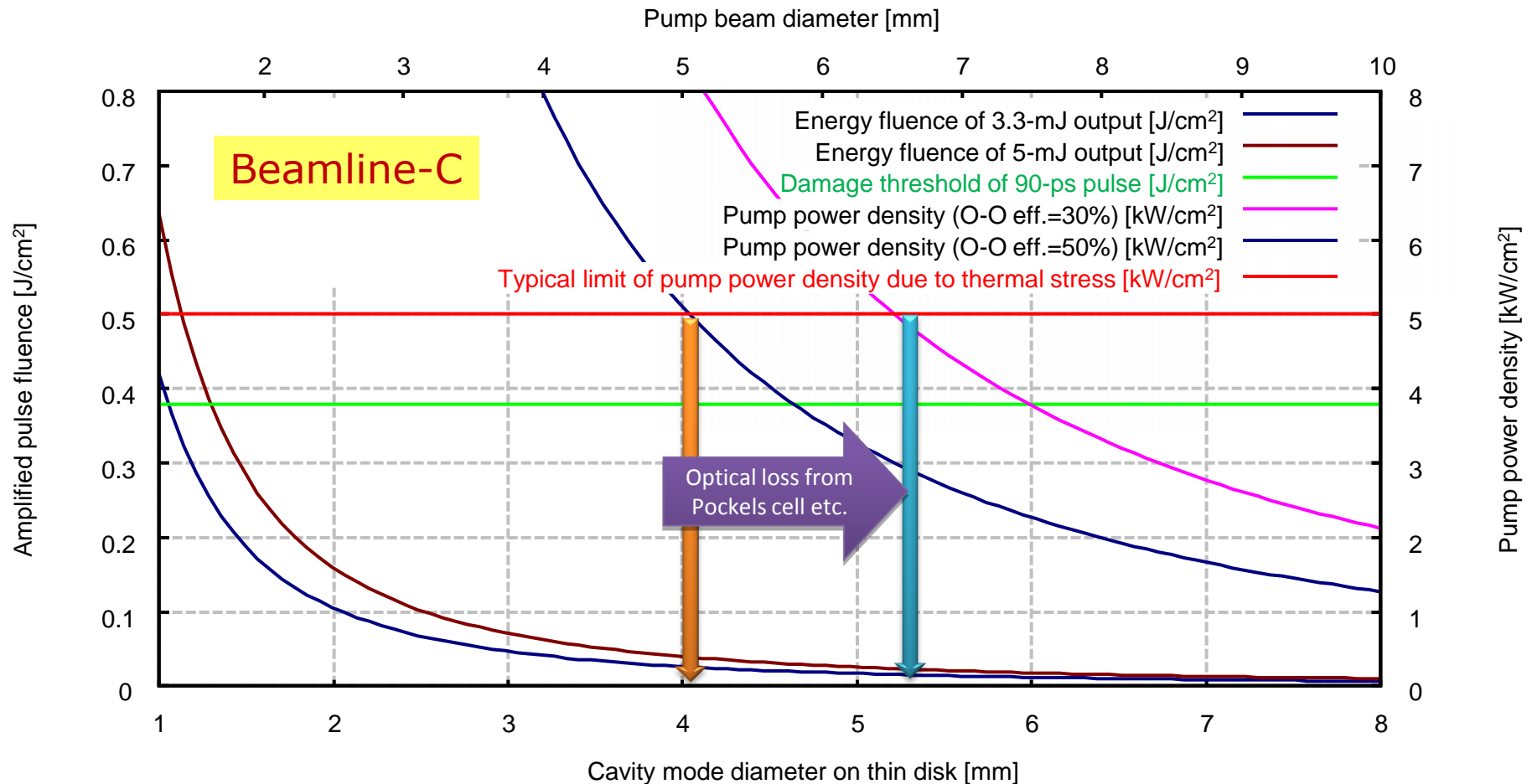
	Dual Thin disk Regen. (MPQ, 2012)	Single Thin disk Regen.[1] (MPQ, 2009)	Single Thin disk Regen.[2] (MBI, 2011)	Single Thin disk Multi-pass[3] (MBI, 2012)	Single Thin disk Multi-pass[4] (DESY, 2012)	Innoslab[5] (DESY, 2011)	Innoslab[5] (DESY, 2011)
Repetition rate [Hz]	1,000,000	3,000	150	100	10 (100kHz burst)	12,500	100,000
Pulse energy [mJ]	0.23	25	305	548	3560 (80 pulses)	20	2
Average output [W]	230	75	45.8	54.8	35.6	250	200
Pump energy [J]	CW	0.1	3.8	6.0	16.1	CW	CW
Pump power [W]	600	280	562.5	600	161.2	600	600
O-O Efficiency [%]	38.3%	26.8%	8.1%	9.1%	22.1%	41.7%	33.3%



- [1] T. Metzger *et al.*, Opt. Lett. **34**, pp. 2123 (2009).
- [2] H. Stiel *et al.*, PTB Seminar EUV Metrology (2011).
- [3] R. Jung *et al.*, Disklaser Workshop (2012).
- [4] M. Schulz *et al.*, Opt. Express **20**, pp. 5038 (2012).
- [5] M. Schulz *et al.*, Opt. Lett. **36**, pp. 2456 (2011).

High energy +  
High average power  
= Challenging

# Scaling Method of Thin Disk Laser for Fundamental-Mode Operation

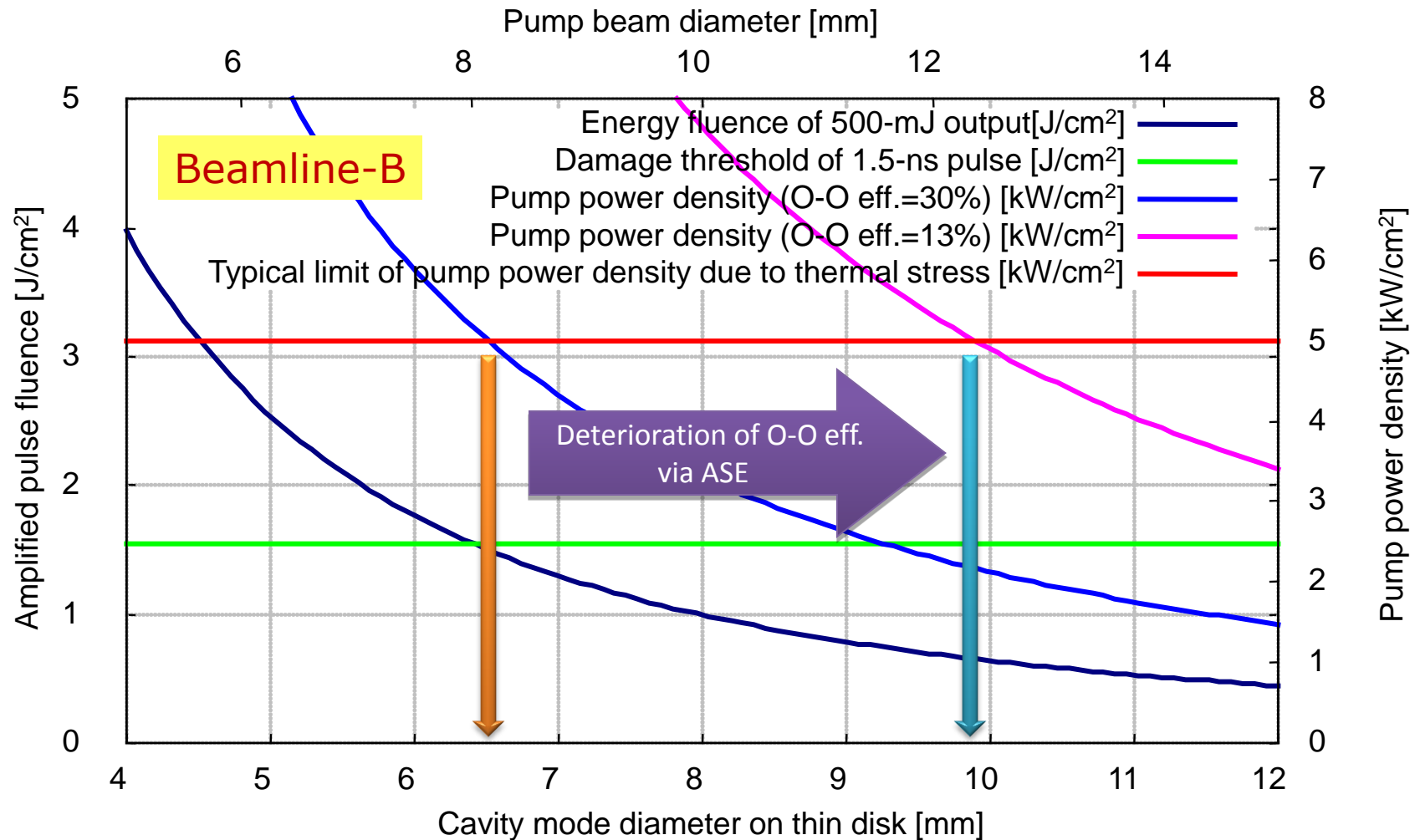


Large diameter thin disk



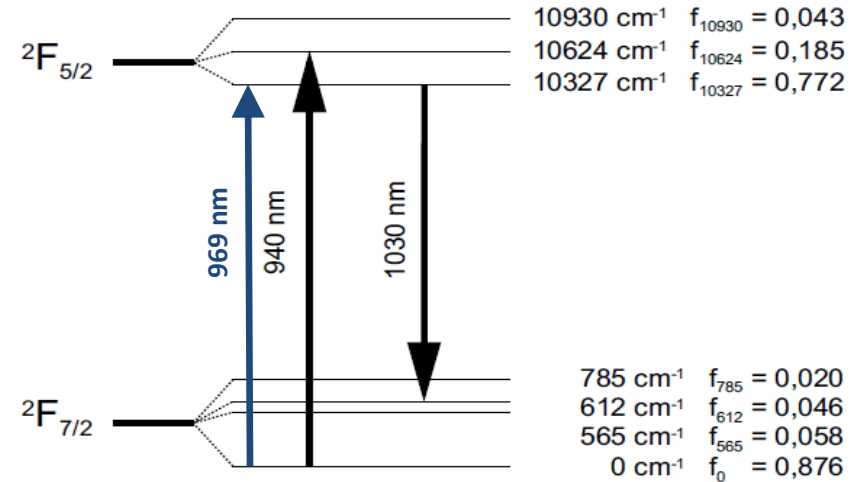
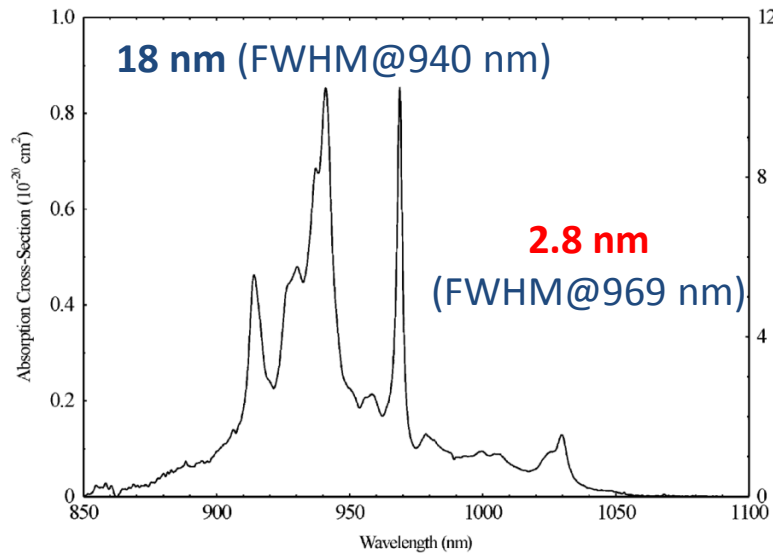
Degradation of beam quality due to higher order optical phase distortion

# Scaling Method of Thin Disk Laser for Fundamental-Mode Operation





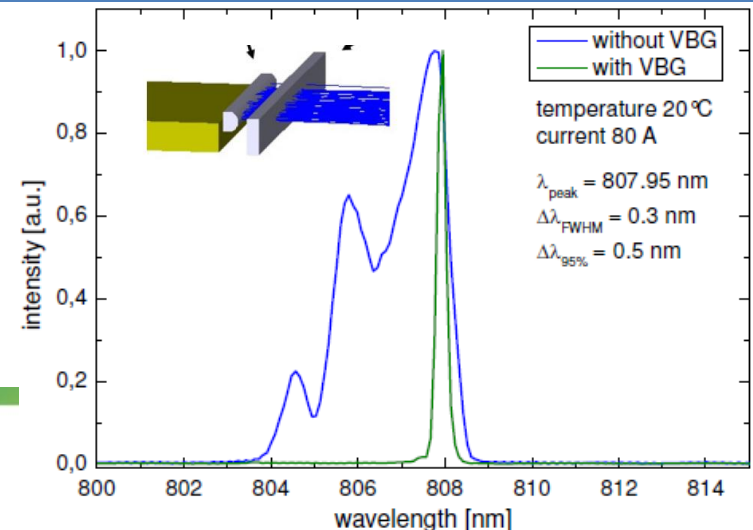
# Improvement of O-O Efficiency via Zero-Phonon Line Pumping



## Advantages of zero-phonon line pumping

- Lower quantum defect  
8.7 % @ 940 nm  
5.9 % @ 969 nm
- Less heat generated in the gain medium  
Smaller deformation of thin disk  
Higher pump density

(ex.) VBG (Volume Bragg Grating) installed narrowband laser diode

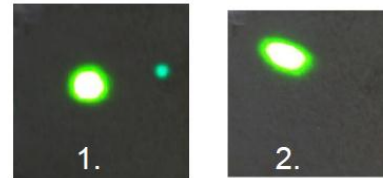
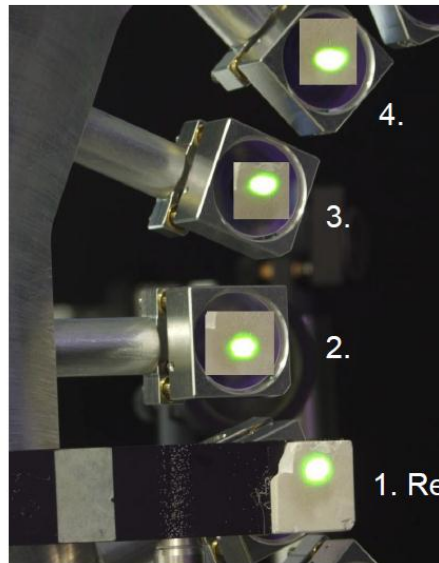


# Beam Distortion Due to The Deformation of Large Size Thin Disk

## Tests of soldered 25mm disks

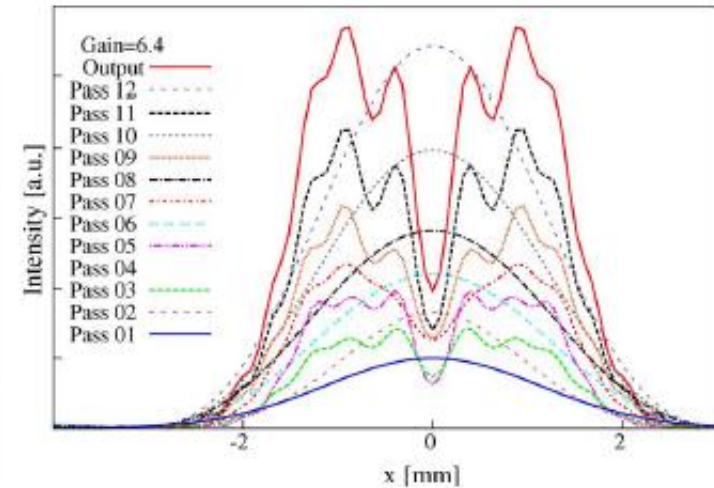


Spherical shape not yet as reproducible as with gluing



Reflection from  
**soldered** Yb:YAG disk

1. Reflection from  
**glued** Yb:YAG disk



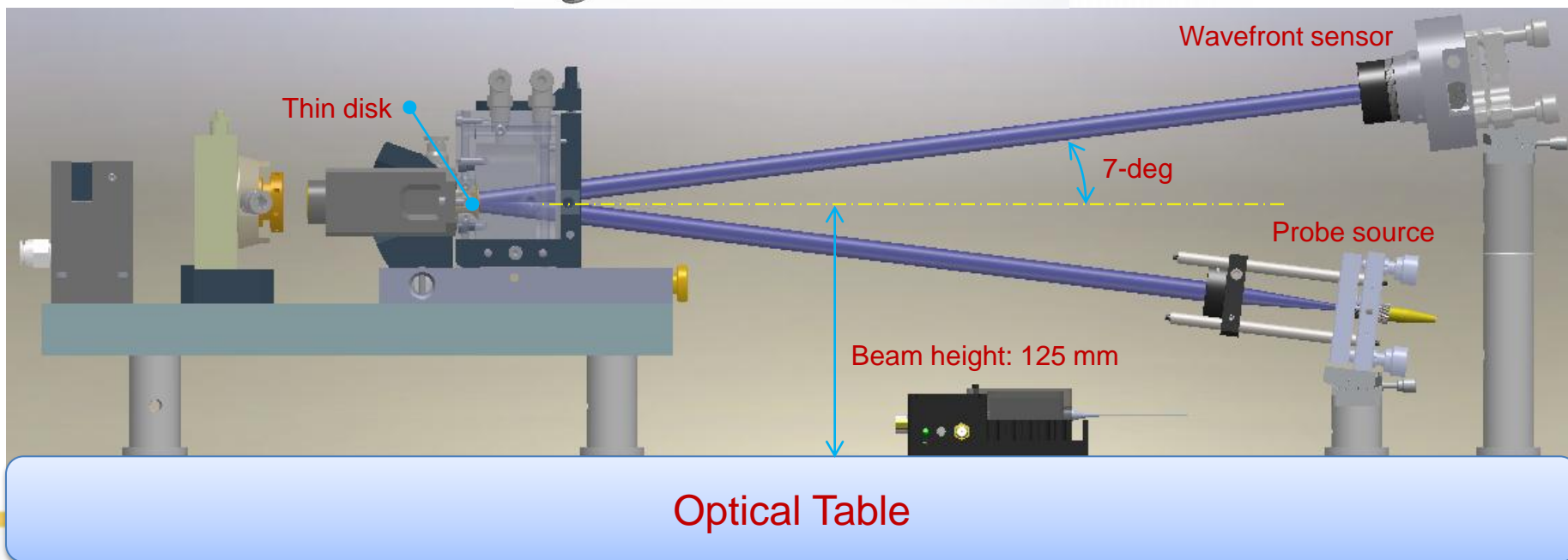
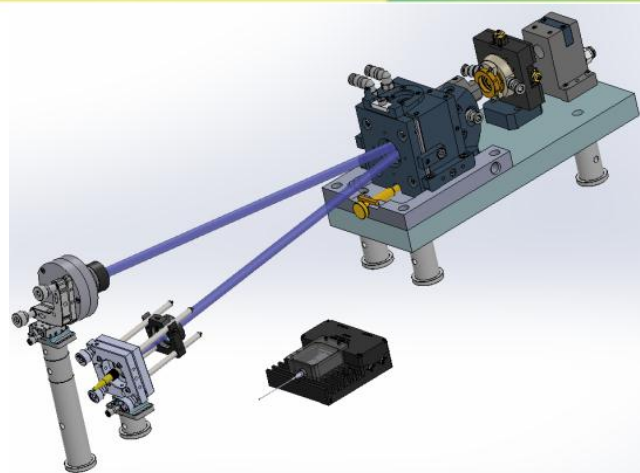
Bifurcation of beam profile from  
thin disk multi-pass amplifier[2]

The real time measurement of thin disk deformation is the key issue.

[1] R. Jung *et. al.*, Disklaser Workshop (2012).

[2] A. Antognini *et. al.*, IEEE J. Quantum Electron. **45**, pp. 993 (2009).

# In-situ Measurement of Thin Disk Deformation Using Wavefront Sensor





# RP1 Group



P. Severova

Analysis by simulations  
Exploring improvements

Comparison with  
numerical model

T. Miura

Evaluation of thin disk  
deformation ,gain (ASE)  
etc.

Suggestions for  
improvement

M. Smrz

O. Novak

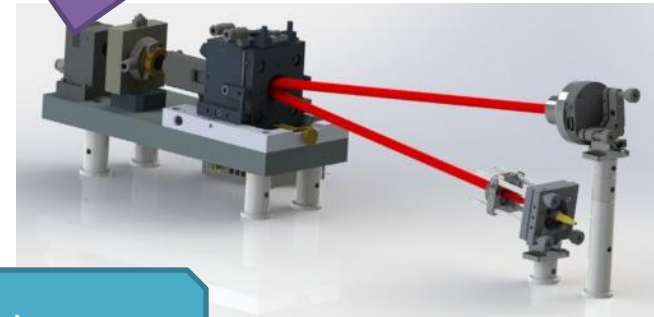
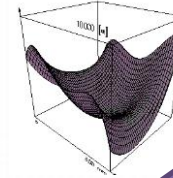
A. Endo  
(RP1  
leader)



M. Chyla

High energy Thin disk  
Regenerative amplifier  
Ring amplifier

Real-time  
measurement

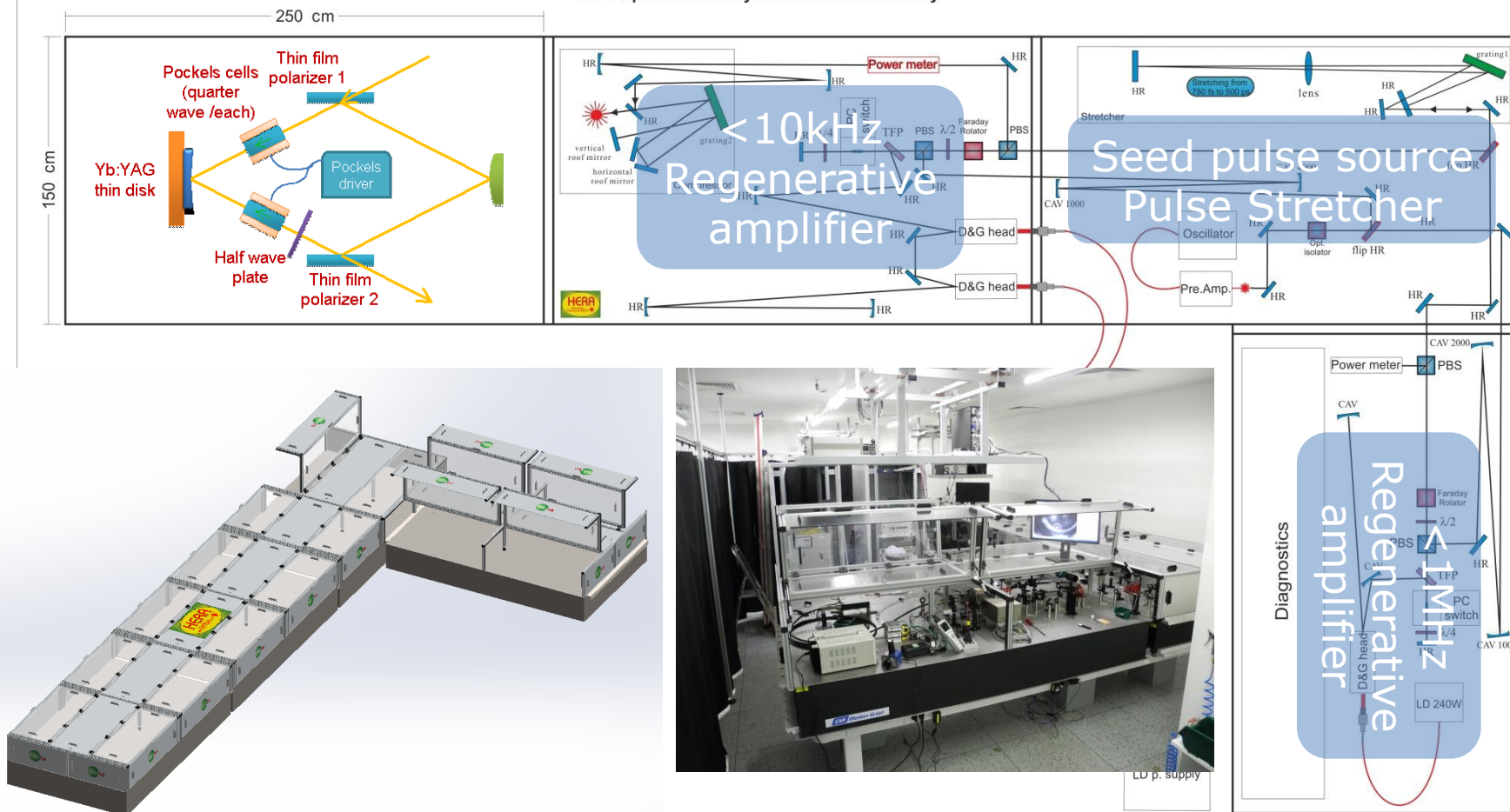


Applications (EUV BEUV HHG ...)

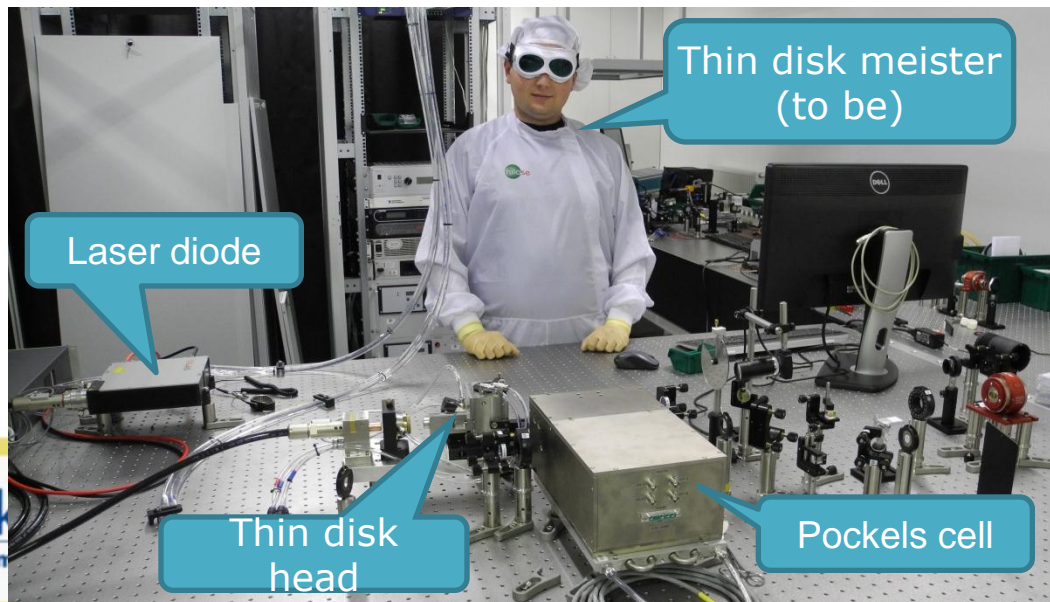
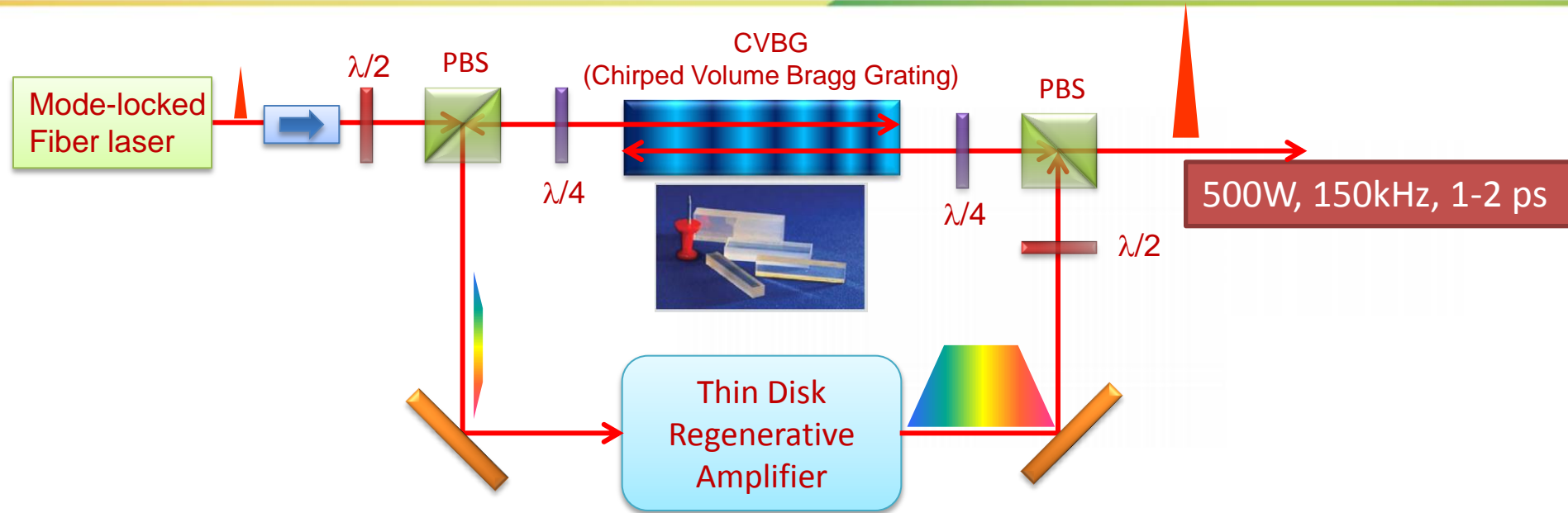


# Fundamental Research Has Been Started

RP 1 Optical tables layout in SOFIA Laboratory

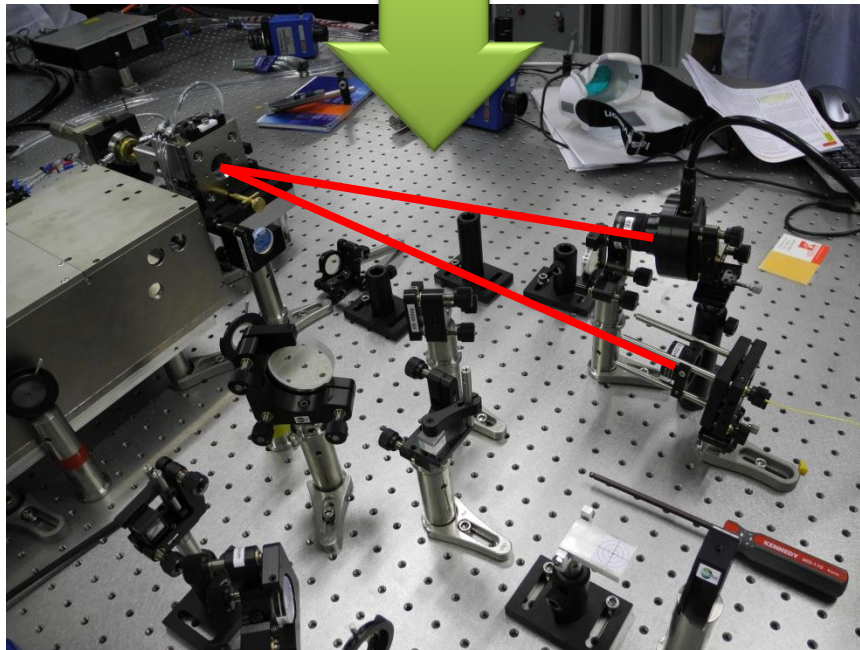
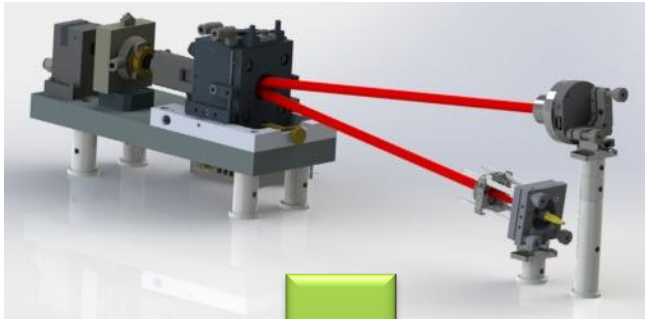


# Table-top High Power Laser Source in HiLASE

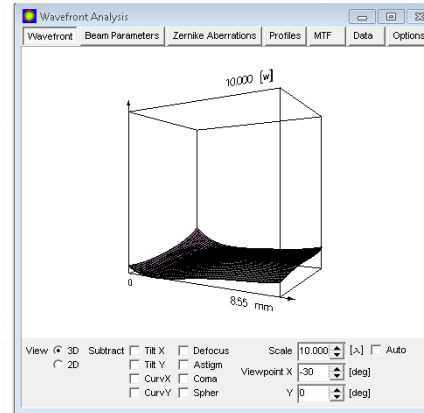




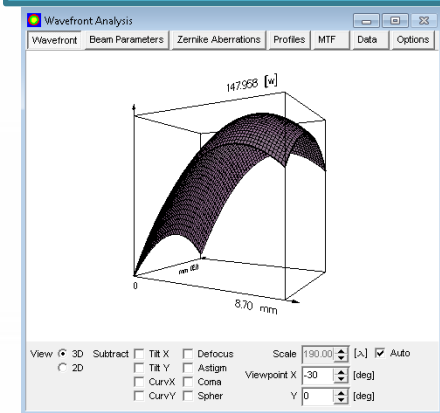
# In-situ Measurement of Thin Disk Deformation



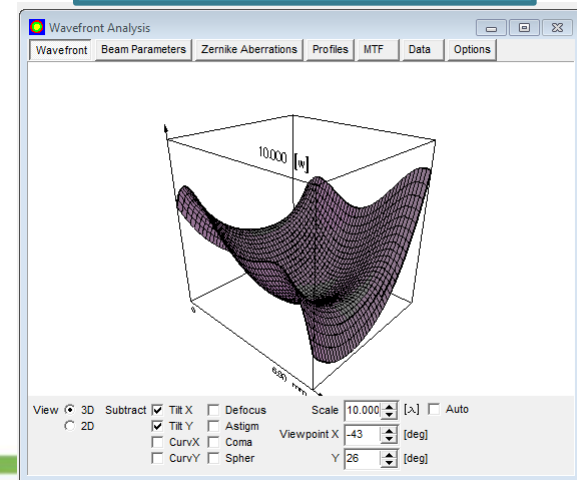
Wavefront from flat



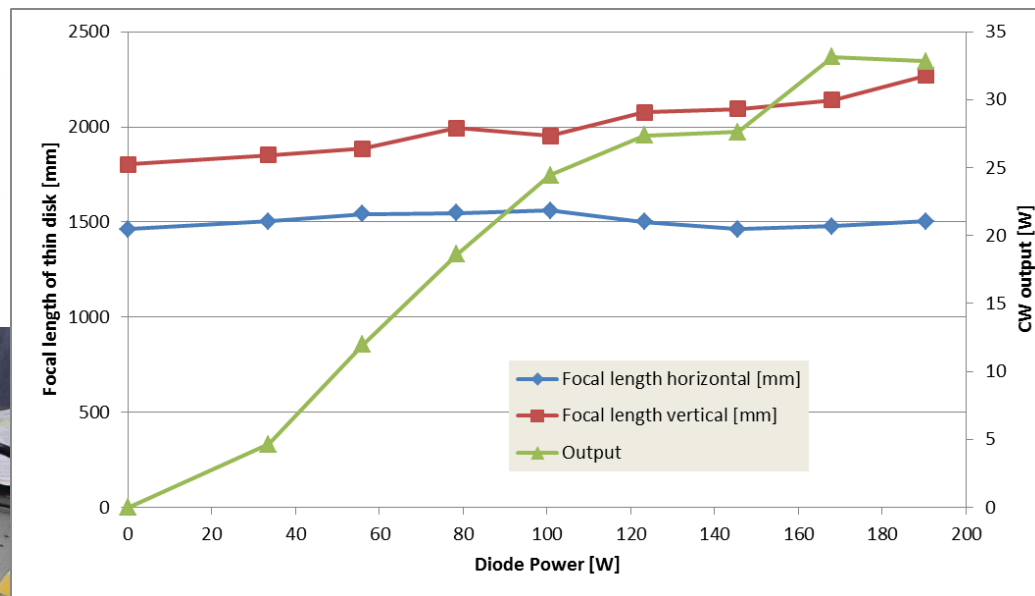
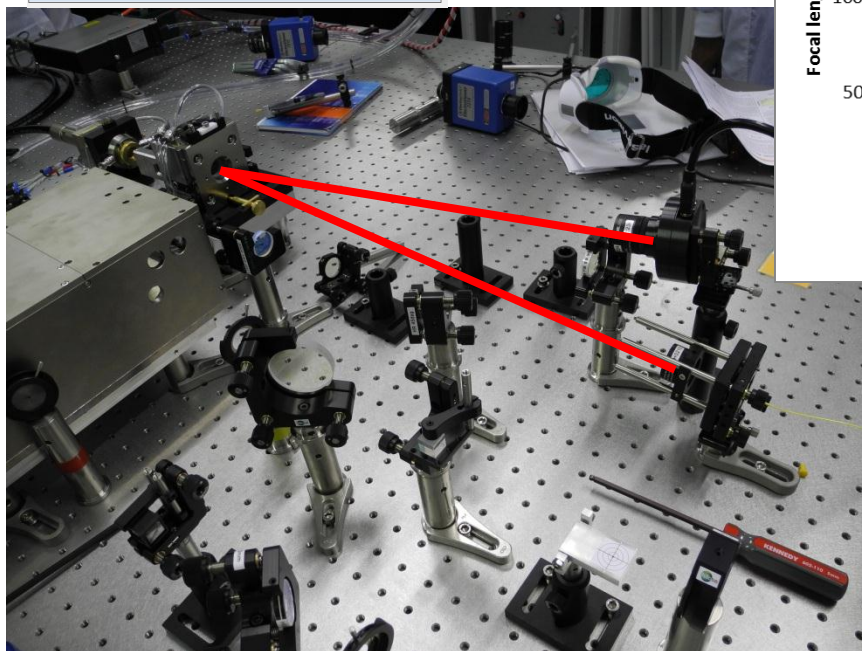
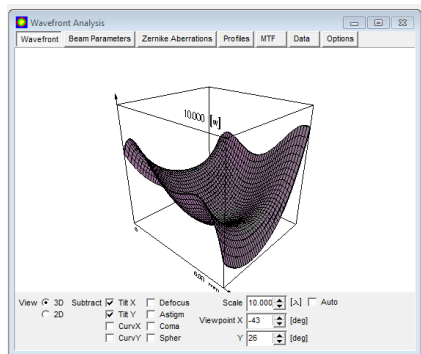
Wavefront from concave mirror (R=400mm)



Wavefront from thin disk



# Preliminary Result of Thin Disk Deformation Measurement



# Summary



- Introduction of the HiLASE Project
- Overview of the beam lines in RP1
- Design concepts of beam line B & C
- Preliminary result of thin disk deformation under the lasing operation
- High energy / high repetition rate amplifiers are under the construction
  - End of this year
    - 100mJ, 1kHz, 1-2ps
    - 1mJ, 100kHz, 1-2ps

